



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 21, 2026

IGI Report Number

LG776620900

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

14.20 X 7.68 X 4.87 MM

GRADING RESULTS

Carat Weight

3.08 CARATS

Color Grade

G

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG776620900

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS

Medium To Slightly Thick (Faceted)

14.5%

44.5%

61%

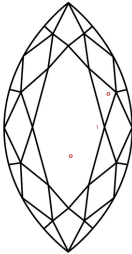
Pointed

63.4%

Sample Image Used



CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



February 21, 2026

IGI Report Number

LG776620900

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

14.20 X 7.68 X 4.87 MM

GRADING RESULTS

Carat Weight

3.08 CARATS

Color Grade

G

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG776620900

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



IGI

February 21, 2026

IGI Report No LG776620900

MARQUISE BRILLIANT

14.20 X 7.68 X 4.87 MM

Carat Weight

3.08 CARATS

Color Grade

G

Clarity Grade

VS 1

Depth

63.4%

Table

61%

Girdle

Medium to Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG776620900

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa